Report on UTFSM/GlueX MPPC test and light guides fabrication projects

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Hall-D Colaboration meeting

October 4 – 5, 2012

Cylindrical electromagnetic calorimeter (BCAL)



MPPC test project (Staff and Roles)

- Director, SiLab Detector Laboratory: Sergey Kuleshov
- Production manager: Javiera Quiroz
- Head engineer: Alam Toro
- Project engineering: Orlando Soto, Rimsky Rojas, René Rios,
- Pavlo Bazalyeyev, Juan (Iñaki) Vega, Martín Cortés.
- Software coordination: Hayk Hakobyan
- Software engineering: Ricardo Oyarzún, Orlando Soto, Juan Pavez
- Director, CCTVal: Ivan Schmidt
- Business and Projects Management, CCTVal: Francisco Soto
- Administrative: Cynthia Sánchez
- **Project Coordination: Will Brooks**

HAMAMATSU product MPPC

Multi Pixel Photon Counter (MPPC) is a solid state photon counter using Geiger-mode APD and self-quenching resistance.

Main features:

- low bias voltage operation
- high gain
- insensitivity to magnetic fields

Three kinds of MPPCS with effective area 1mm x 1mm each:

40 pixels x 40 pixels, 25um pitch, f_{geo} =30.8%

20 pixels x 20 pixels, 50um pitch, f_{geo} =61.5% 10 pixels x10 pixels,100um pitch, f_{geo} =78.5%





HAMAMATSU MPPC Array



Three-station equipment for three stages of MPPC test

- Station 1: visual inspection station which includes a high resolution photographic camera
- Station 2: PDE and pulse shape characteristics measurement taking data with LED/green-fiber light source.
- Station 3: 32-MPPC station using variable intensity LED, can change temperatures over wide range, can measure I-V curves.

Whole system is provided with a MySQL database with a web access: <u>http://atlasusr.fis.utfsm.cl:8000/</u>

Three stages of testing



Camera lens and light sensor

Inspection Station (Stage I)

Camera setup

MPPC image

Fire-resistant safe containing MPPCs

PDE Station (Stage II)



STATION 2 Diagram



Temperature-Controlled Station (Stage III)







STATION 3 Diagram



Peak searching and Background elimination using Markov chain method

The function searches for peaks in source spectrum with technique based on deconvolution method. First the background is removed (if desired), then Markov smoothed spectrum is calculated (if desired), then the response function is generated according to given sigma and deconvolution is carried out. The goal of this function is to identify automatically the peaks in spectrum with the presence of the continuous background and statistical fluctuations - noise.



M. Morháč, J. Kliman, V. Matoušek, M. Veselský, I. Turzo .: NIM, A401 (1997) 113-132.
C. G Ryan et al.: NIM, B34 (1988), 396-402.
M. Morháč, J. Kliman, V. Matoušek, M. Veselský, I. Turzo.: NIM, A443 (2000) 108-125.
M.A. Mariscotti: NIM 50 (1967), 309-320.

MPPC counts spectrum for the same MPPC cell for different voltages



Gain vs. voltage (different channels of the same MPPC)





Result on VOperation = VBreakDown + 0.9 V Gain / 10⁵ 5.4 5.2 5 T = 5°C T = 7°C T = 20°C 4.8 4.6 4.4 4.2 3.8 1500 2000 2500 3000 3500 4000 4500 MPPC ID

Result on V_{Operation} = V_{BreakDown} + 0.9 V



PDE estimation for all MPPCs using information from Station 2



Result on V_{Operation} = V_{BreakDown} + 0.9 V



20

| | Original Plan | Current Plan | Completed |
|---------------------------|----------------|----------------|-----------|
| | Total required | Total required | |
| Receive from Hamamatsu | 2800 | 2800 | 2440 |
| Accepted by Stage 1 | 2800 | 2800 | 2440 |
| Accepted by Stage 2 | 280 | 800 | 2021 |
| Accepted by Stage 3 | 2800 | 2800 | 2400 |
| Shipped to Jlab | 2800 | 2800 | 1520 |

• 4th Bunch with 280 MPPCs scheduled to send on October 9.

Light guides fabrication project (Staff and Roles)

- Head engineer: Juan (Iñaki) Vega
- Machining technicians: Elias Rojas, Karina Jara, Sebastian Cepeda,
- Pavlo Bazalyeyev
- Dimensional control: Cristian de la Cerda, Carlos Gallardo, Felipe

Ponce

- Polishing group leader: Ariel Lobos
- Polishing group technicians: Sergio Sandoval, Juan Gutierrez, Rodrigo
- Lopez, Hugo Briceño, Juan Alarcon, Carlos Montero, Maria Jose Nuñez
- Director, CCTVal: Ivan Schmidt
- Business and Projects Management, CCTVal: Francisco Soto
- Administrative: Cynthia Sánchez
- **Project Coordination: Will Brooks**

Production of 4000 light guides of 10 different geometrical types (shapes) (A, B, C, D, E, F, G, H, J, K) for Hall-D BCAL





3 Stages of Production



STAGE I Milling STAGE II Polishing STAGE III Quality Control (Measuring)

Stage 1 (milling)

5 axis CNC (computer numerical control) milling machine, Datron M8







Stage 2 (polishing)

The polishing procedure is developed in UTFSM based on known techniques from metallography + polishing of telescope mirrors.



As a abrasive material aluminium oxide (Al₂O₃) is used with two types of granuls (5mk in the beggining and 0.3 mk in the end).



Preliminary light guide's dimensional controll is performed on a special template fabricated and sent to UTFSM by Jlab/Hall-D team.



Stage 3 (quality control)



Vision engineering Hawk 5000 monodynascope Provides measurments with 3mk accuracy While lightguides can have ~127mk tolarance Dynascope uses a 148mm diameter multi-lenticular disc surface comprises of over 3.5 million individual lenticules (lenses), each measuring just 70 microns in size. The Dynascope[™] disk spins at 3,400rpm to merge the millions of individual optical paths, delivering a smooth expanded-pupil stereo image with a generous depth of focus and a wide field of view.



| 🗞 QC5000 Part.IG-A_polished | |
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| Trans (rv Tol Artion | |
| Program Properties | |
| Initial settings | 25% |
| Open template "C:\QC5000\Templates\Projects\Lightguides\LG-cotas.5) | 2294 |
| Set @Sn. = or the user's response to "Ingrese numero de serie" | 33/0 |
| Show the message "Cara de mppc arriba y perforacion a la izquierda | 50% |
| Secondary Alignment on "Line 1" | 100% |
| H Measure "Line 2" | |
| Measure "Line 3" | |
| Measure "Line 4" | |
| Construct "Point 5" | |
| Construct "Point 7" | |
| Construct "Foint 8" | |
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| | |
| Construct "Point 17" | Tan |
| | TOP |
| Show the message "Cara de fibras arriba y perforacion a la izquier | |
| Secondary Alignment on "Line 15" | |
| H Measure "Line 16" | |
| Heaving "Line 17" | |
| Headure Phile 10" Construct "Point 22" | |
| Construct "Point 23" | |
| Construct "Point 24" | |
| E Construct "Point 25" | •• • |
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| E < | |
| Show the message "Montar guia de luz en machina y perforacion haci- | ••••••••••••••••••••••••••••••••••••••• |
| B Secondary Alignment on "Line 31" | |
| U U Carlo Ca | |
| 28-9-12 Cartesian MM Ved Probes 2X VED XY Temp DD NI EC On Auto Enter Off editing | |
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For one lightguide fabrication: STAGE 1 ~ 20 min STAGE 2 ~ 20 min STAGE 3 ~ 7 min

Number of lightguides produced per day: STAGE 1 – 60 STAGE 2 – 60 STAGE 3 – 30

One day per week is dedicated to milling machine maintenance.

| JP-TO-D | ATE fabricated: |
|---------------|--------------------|
| A – 31 | G – 25 |
| 3 – 97 | H – 1 |
| C – 15 | J – 15 |
| D – 43 | K – 18 |
| E – 47 | |
| = – 41 | TOTAL – 333 |
| | 33 |

BACKUP SLIDES



PDE Station Light Source

Recessed positioner; fibers on this side, MPPC on other side

Light mixer (clear fiber goes into center)





Blue LED feeding clear fiber



Output of 16 green fibers following mixer



Completely automatic fit based on Markov method from spectroscopy Fit was performed for 3(temperature)x2(dark/LED)x13(voltage)x16(channels)=1248 cases for each MPPC.³⁶ For all fits 1<Chi²<2.2

From these histograms we get gain (G_i), average number of photoelectrons (μ_i), cross-talk probability ($\Delta \mu_i$) according to:



Gain vs. voltage (different channels of the same



MPPC characteristics measurements results from stage 3

